

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: NEO C. PENG ET AL.

Examiner: Samuel M Heinrich

Serial No.: 10/823,314

Group Art Unit: 1725

Filed: April 13, 2004

Docket: 303.772US2

Title: WAFER DICING DEVICE AND METHOD

RESPONSE TO RESTRICTION REQUIREMENT

MS Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

In response to the Restriction Requirement mailed May 29, 2007, Applicant submits the following.